## In the Claims

This listing of claims will replace all prior versions, and listings, of claims in the application:

- 1-6. (Cancelled)
- 7. (Currently Amended) A high frequency substrate, comprising at least:
- a first metal layer;
- a first dielectric layer on the first metal layer, wherein the first dielectric layer is made of a high dielectric coefficient material;
  - a second metal layer on the first dielectric layer;
- a second dielectric layer on the second metal layer, wherein the second dielectric layer comprises a first opening;
- a third dielectric layer within the first opening and on the second metal layer, wherein the third dielectric layer is made of a low dielectric coefficient material, and a dielectric coefficient of the third dielectric layer is smaller than a dielectric coefficient of the second dielectric layer; and
  - a high-frequency signal transmission line on the third dielectric layer.
- 8. (Withdrawn) The high frequency substrate according to claim 7, wherein the second dielectric layer further comprises a second opening.

- 9. (Withdrawn) The high frequency substrate according to claim 8, wherein the high-frequency substrate further comprises:
- a fourth dielectric layer within the second opening and on the second metal layer, wherein the fourth dielectric layer is made of a high dielectric coefficient material; and
  - a low-frequency signal transmission line on the fourth dielectric layer.
- 10. (Original) The high frequency substrate according to claim 7, wherein the second dielectric layer is made of a high dielectric coefficient material.
- 11. (Original) The high frequency substrate according to claim 10, wherein the high-frequency substrate further comprises a low-frequency signal transmission line on the second dielectric layer.
- 12. (Original) The high frequency substrate according to claim 7, wherein the value of the dielectric coefficient for the high dielectric coefficient material is more than 4.
- 13. (Original) The high frequency substrate according to claim 7, wherein the low dielectric coefficient material is polytetrafluroethylene (PTFE)

- 14. (Original) The high frequency substrate according to claim 7, wherein the value of the dielectric coefficient for the low dielectric coefficient material is less than 4
- 15. (Currently Amended) The high frequency substrate according to claim 7, wherein the a top superficial measure surface area of the third dielectric layer is equal to or larger than the a bottom superficial measure surface area of the high-frequency signal transmission line.
  - 16. (Currently Amended) A substrate, comprising at least:
- a first dielectric layer which comprises an opening, wherein the first dielectric layer is made of a high dielectric coefficient material;
- a second dielectric layer within the opening, wherein a dielectric coefficient of the second dielectric layer is smaller than a dielectric coefficient of the second dielectric layer; and a signal transmission line on the second dielectric layer.
- 17. (Original) The substrate according to claim 16, wherein the second dielectric layer is made of a low dielectric coefficient material and the signal transmission line is a high-frequency signal transmission line.
- 18. (Original) The substrate according to claim 17, wherein the value of the dielectric coefficient for the low dielectric coefficient material is less than 4

- 19. (Withdrawn) The substrate according to claim 16, wherein the second dielectric layer is made of a high dielectric coefficient material and the signal transmission line is a low-frequency signal transmission line.
- 20. (Withdrawn) The substrate according to claim 19, wherein the value of the dielectric coefficient for the high dielectric coefficient material is more than 4.
  - 21-28. (Cancelled)
- 29. (New) The high frequency substrate according to claim 7, wherein the first metal layer is a ground plane and the second metal layer is a power plane.
- 30. (New) The high frequency substrate according to claim 7, wherein the first metal layer is a power plane and the second metal layer is a ground plane.
- 31. (New) The substrate according to claim 16, wherein the first dielectric layer is made of a high dielectric coefficient material.

- 32. (New) The high frequency substrate according to claim 31, wherein the high-frequency substrate further comprises a low-frequency signal transmission line on the second dielectric layer.
- 33. (New) The substrate according to claim 31, wherein the value of the dielectric coefficient for the high dielectric coefficient material is more than 4.
- 34. (New) The substrate according to claim 17, wherein the low dielectric coefficient material is polytetrafluroethylene (PTFE)
- 35. (New) The high frequency substrate according to claim 17, wherein the value of the dielectric coefficient for the low dielectric coefficient material is less than 4
- 36. (New) The high frequency substrate according to claim 16, wherein a top surface area of the second dielectric layer is equal to or larger than a bottom surface area of the high-frequency signal transmission line.